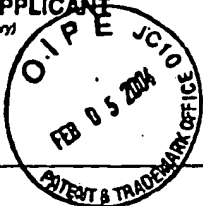




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**INFORMATION DISCLOSURE  
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Applicati n Number	09/945,507
Filing Date	August 30, 2001
First Named Inventor	Forbes, Leonard
Group Art Unit	2824
Examiner Name	Dinh, Son

Sheet 1 of 3

Attorney Docket No: 1303.014US1

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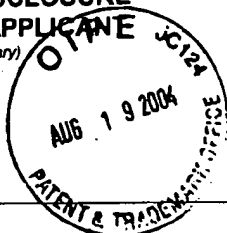
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	Application Number	09/945,507
	Filing Date	August 30, 2001
	First Named Inventor	Forbes, Leonard
	Group Art Unit	2824
	Examiner Name	Dinh, Son
Sheet 1 of 1	Attorney Docket No: 1303.014US1	



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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS					
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Application Number 09/945,507  
 Filing Date August 30, 2001  
 First Named Inventor Forbes, Leonard  
 Group Art Unit 2824  
 Examiner Name Dinh, Son

Sheet 3 of 3

Attorney Docket No: 1303.014US1

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